

Notice of References Cited	Application/Control No. 10/821,608		Applicant(s)/Patent Under Reexamination AGRAWAL ET AL.	
	Examiner BACKHEAN TIV		Art Unit 2451	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,456,854	09-2002	Chern et al.	455/457
	B	US-			
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

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